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Patent Application ATM-515 (7486)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Docket No.:

ATMI-515 (7486)

Applicant:

XU, Chongying, et al.

Examiner:

Virginia MANOHARAN

Application No.:

10/015,326

Art Group: 1

1764

Date Filed:

Confirm. No.:

2946

December 13, 2001

Customer No.:

Title:

METHOD FOR REMOVAL OF IMPURITIES IN CYCLIC SILOXANES USEFUL AS PRECURSORS FOR LOW DIELECTRIC CONSTANT

THIN FILMS

25559

FACSIMILE TRANSMISSION CERTIFICATE ATTN: Examiner Virginia MANOHARAN

Fax No.: (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on July 25, 2005, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300

Number of Pages (including cover)

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Marianne Fuierer

July 25, 2005

Date

RESPONSE TO MAY 25, 2005 OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 10/015,326

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the May 25, 2005 Office Action, please amend the application as follows: